

<b>Notice of References Cited</b>	Application/Control No. 10/670,850		Applicant(s)/Patent Under Reexamination HWANG ET AL.	
	Examiner Michael C. Zarroli		Art Unit 2839	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,093,028 A	07-2000	Yang, Wen-Yuan	439/13
*	B	US-5,954,519 A	09-1999	Hsiao, Hsu-Ting	439/21
*	C	US-5,711,674	01-1998	Chu, Shu-Hsun	439/11
*	D	US-3,092,695	06-1963	RALPH ABRAMS	200/51R
*	E	US-5,352,122 A	10-1994	Speyer et al.	439/13
*	F	US-5,683,254	11-1997	Lin, Chiu-Chen	439/11
*	G	US-6,488,510 B2	12-2002	Li, Ron Chung	439/13
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

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